	Sp	pecification of	D .			
			Piezo	electric [Diaphragi	m
			7NB-4	1-1		
	决定年月日 Date	March 25, 2009		承 認 Approved by	確認 Checked by	担 当 Issued by
1.	適用 Scop	9				
2.	品番 及び 貴	社関連事項 Part Nur	mber			
3.	2-2 貴社部品 Custome 2-3 貴社仕様	Part Number 番号 er's Part Number 書番号 er's Drawing Number	:7NB-41- : :	1		
3.	Murata F 2-2 貴社部品 Custome 2-3 貴社仕様 Custome	Part Number 番号 er's Part Number 書番号 er's Drawing Number	:7NB-41- : :	1	格 Specific	ation
3.	Murata F 2-2 貴社部品 Custome 2-3 貴社仕様 Custome 最大定格 Ma 3-1 動作温度範	Part Number 番号 er's Part Number 書番号 er's Drawing Number ximum Rating 項目 Item 范囲	:7NB-41- : :		-20 ~ +70	ation
	Murata F 2-2 貴社部品 Custome 2-3 貴社仕様 Custome 最大定格 Ma 3-1 動作温度範	Part Number 番号 er's Part Number 書番号 er's Drawing Number ximum Rating 項目 Item 如田 Temperature Range	:7NB-41- : :		•	ation

	項目 Item	規格 Specification
4-	1 共振周波数	0.8 ± 0.3kHz
	Resonant Frequency	0.0 ± 0.3ki iz
4-		600 以下/max.
	Resonant Impedance	
4-		75nF ± 30%
	Electrostatic Capacity (at 120Hz)	
4-		100MΩ以上
	Insulation Resistance (at 10VD.C.) 測定条件は次項を参照して下さい。	<u>100Μ</u> Ωmin.
	測定宗件は次項を参照して下さい。 Refer to next item for measuring method.	
'	terer to next item for measuring method.	
-	測定方法 Measuring Method	
	5-1 共振周波数/共振抵抗について Resonant	r Frequency / Resonant Impedance
	ベクトルインピーダンスメータ(又は同等品)を用いて、下図の様に振動板を節部にて
	保持します。(空中 宙吊り状態)	
	周波数0~4kHzを変化させた時、インピーダ	ンスが最小となる周波数を、共振周波数と
	し、その時のインピーダンスを共振抵抗とし	+ -
	Piezoelectric diaphragm shall be clamped at	a node point as shown in following figure to
	Piezoelectric diaphragm shall be clamped at be free from any mechanical stress, and mea	a node point as shown in following figure to asured its resonant frequency and resonant
	Piezoelectric diaphragm shall be clamped at be free from any mechanical stress, and mea impedance by using vector impedance analyz	a node point as shown in following figure to asured its resonant frequency and resonant zer or equivalent.
	Piezoelectric diaphragm shall be clamped at be free from any mechanical stress, and mea impedance by using vector impedance analyz When the input frequency is sweeped with defined the frequency where the impedance	a node point as shown in following figure to asured its resonant frequency and resonant zer or equivalent. hin 0 to 4 kHz, the resonant frequency is
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5-4	4 測定条件 Meas	suring Condition			
温度+25±3 ,湿度60±10%R.H.を標準測定状態とし,特に疑義を生じない場合は、 温度+5~+35 ,湿度45~85%R.H.の範囲内で測定します。 Parts shall be measured under a condition (Temperature:+5 to +35°C, Humidity: 45 to 85%R.H.)unless the standard condition (Temperature:+25±3°C, Humidity: 60±10%R.H.) is regulated to measure.					
6. 機柄	戒的性能 Physical(Characteristics			
	試験項目	試 験 条 件	試験後の規格		
	Item	Test Condition	Specification		
6-1	耐衝撃性	加速度 980m/s ² 、半波正弦波の衝撃を XYZ			
		の3方向に各3回印加後、測定します。			
	Shock	Diaphragm shall be measured after being ap-			
		plied shock(980m/s ²) for each three mutually			
		perpendicular directions to each of 3 times by	第1表を満足しま		
		half sine wave.	す。		
6-2	耐振動性	振動周波数 10~55Hz,全振幅 1.5mm の振動	The measured		
		を XYZ の 3 方向に各 2 時間印加後、測定しま	value shall meet		
		す。	Table 1.		
Vibration		Diaphragm shall be measured after being ap-			
	Resistant	plied vibration of amplitude of 1.5mm with 10 to			
		55Hz band of vibration frequency to each of 3			
		perpendicular directions for 2 hours.			

7. 耐候性能 Environmental Characteristics

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	\backslash	試験項目	試験条件	試験後の規格
		Item	Test Condition	Specification
	7-1	高温放置	温度+85±2 に 240 時間保持し、常温に取	
			出し4時間放置後測定します。	
		Dry Heat Test	After being placed in a chamber with +85±2°C	
		(Storage)	for 240 hours and then being placed in natural	第1表を満足しま
			condition for 4 hours, diaphragm shall be	
			measured.	The measured val-
	7-2	低温放置	温度-40±2 に 240 時間保持し、常温に取出	ue shall meet Table
			し4時間放置後測定します。	
		Cold Test	After being placed in a chamber with -40±2°C	
		(Storage)	for 240 hours and then being placed in natural	
			condition for 4 hours, diaphragm shall be	
			measured.	

7-3	耐湿性	温度+40±2 ,湿度 90~95%R.H.の恒温恒		
		湿槽中に 240 時間保持し、常温に取り出し 4 時		
		間放置後測定します。		
	Humidity	After being placed in a chamber with 90 to		
		95%R.H. at +40±2°C for 240 hours and then		
		being placed in natural condition for 4 hours,		
		diaphragm shall be measured.		
7-4	温度サイクル	温度-40±2 の恒温槽中に 30 分間保持後室		
		温(+20)に15分間保持し、更に温度+85±2	第1表を満足しま	
		の恒温槽中に 30 分保持後、室温(+20)に 15	- 第一衣を胸定しよ	
		分間保持します。これを1サイクルとして5サ	The measured	
		イクル行い、常温に4時間放置後測定します。	value shall meet	
	Temperature Cycle	After being placed in a chamber at -40±2°C for	Table 1.	
		30 minutes, diaphragm shall be placed at room		
		temperature(+20°C). After 15 minutes at this		
		temperature, diaphragm shall be placed in a		
		chamber at +85±2°C. After 30 minutes at this		
		temperature, diaphragm shall be returned to		
		room temperature(+20°C) for 15 minutes.		
		After 5 above cycles, diaphragm shall be		
		measured after being placed in natural condition		
		for 4 hours.		

表1 Table 1.

項目	▼ 試験後の変化量
Item	Specification after test
共振周波数	初期值 ± 10%
Resonant Frequency	Initial Value±10%
共振抵抗	1.2kΩ以下
Resonant Impedance	1.2kΩmax.
静電容量	初期值 ± 20%
Electrostatic Capacity	Initial Value±20%

株式会社 村 田 製 作 所 Murata Manufacturing Co.,Ltd.

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仕様書番号 Drawing No. JGB45-0173B



	11. 使	用上の注意 Caution for Use
	11-1	本体を素手で扱わないで下さい。本体を素手で扱うと、短期間で錆が生じます。 Please do not touch the component with bare hand because electrode may be corroded.
	11-2	本体中央部に荷重をかけると、セラミックにクラックを生じることがあります。 周辺支持にて使用する際は、支持部のみに荷重をかけて取り扱って下さい。 Applying load on the center area of the diaphragm may cause clack in the ceramic element. When the diaphragm is supported by edge, the load should be only applied around edge.
	11-3	本体に規格以上の衝撃が印加された場合、不具合を生じることがありますので、 取扱いには十分にご注意下さい。 The component may be damaged if mechanical stress over this specification is applied.
	11-4	落下衝撃,熱衝撃によりサージ電圧が発生しますので、回路設計には十分ご注意下 さい。 Please pay attention to protect operating circuit from surge voltage provided by some- thing of force such as falling, shock and temperature changing.
	11-5	本体に直流電圧を印加された場合、不具合を生じることがありますので、回路設計 には十分注意して下さい。 Please pay attention never to be applied DC voltage to piezo diaphragm.
	11-6	圧電振動板にはんだ付される場合は必ずご相談下さい。 Please consult with Murata or Murata representative, in case of soldering on piezoelectric diaphragm.
	11-7	IC等により駆動する際、安定鳴動及びIC保護用にIC出力端と本体に直列抵抗約1~2k を挿入するか、本体と並列にダイオードを挿入して、ご使用下さい。 The resistor should be used as shown in Fig. A. A suitable resistance value should be chosen, preferably 1kΩ to 2kΩ. Instead of this measure, a diode may also be applied as shown in Fig. B.
		Fig.A Fig.B
L		

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Murata Manufacturing Co., Ltd.

株式会社村田製作所

12.製品(呆管上の注意 Notice on Product Storage
12-1	温度-10~+40 、相対湿度15~85%で、急激な温湿度変化のない室内で保管下さい。 Please store the products in room where the temperature / humidity is stable. And avoid such places where there are large temperature changes. Please store the products under the following conditions : Temperature : -10 to +40 (degree C) Humidity : 15 to 85% R.H.
12-2	製品保管期限は未開梱、未開封状態にて、納入後6ヶ月間です。納入後6ヶ月以内でご使 用下さい。6ヶ月を越える場合ははんだ付け性等をご確認の上、ご使用下さい。 Expire date (Shelf life) of the products is 6 months after delivery under the conditions of a sealed and an unopened package. Please use the products within 6 months after delivery. If you store the products for a long time (more than 6months), use carefully because the products may be degraded in the solder-ability and/or rusty. Please confirm solder-ability and characteristics for the products regularly.
12-3	酸、アルカリ、塩、有機ガス、硫黄等の化学的雰囲気中で保管されますとはんだ付け性 の劣化不良等の原因となりますので、化学的雰囲気中での保管は避けて下さい。 Please do not store the products in a chemical atmosphere (Acids, Alkali, Bases, Organic gas, Sulfides and so on), because the characteristics may be reduced in quality, and/or be degraded in the solder-ability due to the storage in a chemical atmosphere.
12-4	湿気、塵等の影響を避けるため、床への直置きは避けて保管下さい。 Please do not put the products directly on the floor without anything under them to avoid damp places and/or dusty places.
12-5	直射日光、熱、振動等が加わる場所での保管は避けて下さい。 Please do not store the products in the places such as : in a damp heated place, in a place where direct sunlight comes in, in place applying vibrations.
12-6	開梱、開封後、長期保管された場合、保管状況によっては、はんだ付け性等が劣化する 可能性があります。開梱、開封後は速やかにご使用下さい。 Please use the products immediately after the package is opened, because the characteristics may be reduced in quality, and/or be degraded in the solder-ability due to storage under the poor condition.
12-7	製品落下により、製品内部のセラミック素子の割れ等の原因となりますので、容易に落下しない状態での保管とお取扱いをお願い致します。 Please do not drop the products to avoid cracking of ceramic element.

13. <u>小</u>お願い Note

- 13-1 ご使用に際しましては、貴社製品に実装された状態で必ず評価して下さい。 Please make sure that your product has been evaluated in view of your specifications with our product being mounted to your product.
- 13-2 当製品を当納入仕様書の記載内容を逸脱して使用しないで下さい。 You are requested not to use our product deviating from this product specification.

13-3 お手数ですが、当納入仕様書に貴社受領印を押印の上、1部を弊社へご返却下さい。 3ヶ月以内にご返却いただけない場合、又は、当納入仕様書をご返却いただく前にご注 文をいただいた場合は、当納入仕様書は、その時点で受領されたものとさせていただき ます。

Please return one duplicate of this product specification to us with your signature to acknowledge your receipt . In case of no return within three months from submission date, or if we receive order before the duplicate is returned, this product specification will be deemed to have been received by you.

13-4 弊社は、仕様書、図面その他の技術資料には、取引に関する契約事項を記載することは 適切ではないものと存じております。従って、もし、貴社が作成されたこれら技術資料 に、品質保証、PL、工業所有権等にかかる弊社の責任の範囲に関する記載がある場合 は、当該記載は無効とさせていただきます。これらの事項につきましては、別途取引基 本契約書等においてお申し越しいただきたくお願いします。

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